

Docket No.: M4065.0567/P567-A  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:

Paul J. Rudeck

Allowed: March 28, 2008

Application No.: 10/626,620

Confirmation No.: 9373

Filed: July 25, 2003

Art Unit: 2813

For: METHOD TO REMOVE AN OXIDE  
SEAM ALONG GATE STACK EDGE,  
WHEN NITRIDE SPACER FORMATION  
BEGINS

Examiner: L. M. Schillinger

**COMMENTS ON STATEMENT OF REASONS  
FOR ALLOWANCE UNDER 37 CFR §1.104(E)**

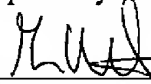
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicant agrees in part with the Examiner's Statement of Reasons for Allowance in that the prior art of record fails to disclose, teach, or suggest the claimed invention. However, Applicant notes that the Examiner's statement fails to address the limitations of the allowed claims except in a general cursory manner. Each claim, including the dependent claims, defines a unique combination of features not taught or suggested by the prior art and providing additional reasons for allowance.

Dated: June 30, 2008

Respectfully submitted,

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